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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Jyunichi NAKAMURA et al. Confirmation No.: 5720
Serial No.: 10/649,745 Art Unit: 2826
Filed: August 28, 2003 Examiner: A. WILLIAMS
For: **MULTILAYERED SUBSTRATE** Atty Docket No: 060914-117-US
FOR SEMICONDUCTOR
DEVICE

AMENDMENT AFTER FINAL REJECTION

Box AF
U.S. Patent and Trademark Office
Randolph Building
104 Dulany Street
Alexandria, Virginia 22314

Sir:

In response to the outstanding second Final Office Action dated September 9, 2005,
please amend the above-referenced patent application as follows.

Amendments to the claims begin at page 2; and

Remarks begin at page 5 of this Amendment.